INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 29, 2025

IGI Report Number	LG700571638
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.63 - 6.66 X 4.08 MM

GRADING RESULTS

Carat Weight	1.10 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

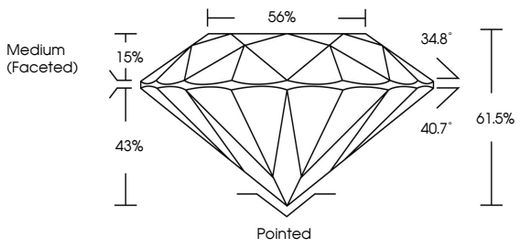
ADDITIONAL GRADING INFORMATION

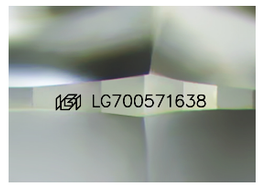
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG700571638

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG700571638
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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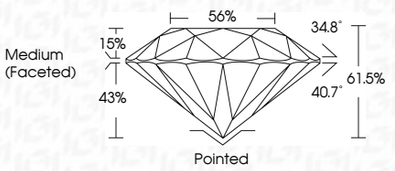
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IGI

April 29, 2025
IGI Report No LG700571638
ROUND BRILLIANT
6.63 - 6.66 X 4.08 MM
Carat Weight 1.10 CARAT
Color Grade D
Clarity Grade VVS 2
Cut Grade IDEAL
Depth 61.5%
Table 55%
Girdle Medium (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG700571638
Comments:
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Type IIa